

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Goo et al.

Examiner: Gutierrez, Kevin C

Serial No: 10/807,659

Group Art Unit: 2851

Filed: March 24, 2004

Docket: 8836-229 (IE 12193US)

**FOR: WAFER EDGE EXPOSING APPARATUS**

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Alexandria, VA 22313-1450

**AMENDMENT UNDER 37 C.F.R. 1.116**

In response to the Office Action dated May 31, 2007, please amend the above-identified application as follows. Also, accompanying this amendment is a Request for Continued Examination (RCE).